

# FSRM

Swiss foundation for  
research in microtechnology

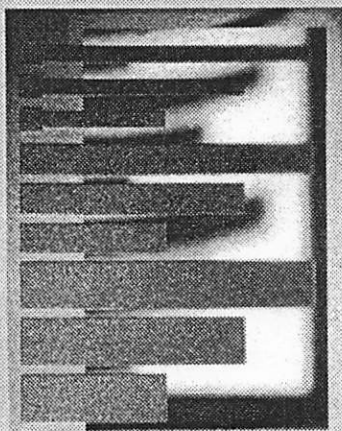
# UETP MEMS

## FOR TRAINING IN MICROSYSTEMS

A project supported by the EC under the **COMETT** Programme

### APPLICATION ORIENTED COURSES

#### HANDS ON MEMS



UETP-MEMS

Micromachined structure realized by the participants in the 3 days course HANDS ON MEMS.

This course is run in the cleanroom facilities of the University of Neuchâtel, the University of Twente, the Hahn-Schickard-Gesellschaft of Villingen, the Institut des Microtechniques at Besançon.

- Micro Actuators
- Etching Technology
- Hands on MEMS
- Packaging
- CAD Tools for MEMS

*NEW, starting in 1994:*


- LIGA Technique
- Chemical microsensors
- Resonant microsensors
- Interface analysis
- Optical measurement

*UETP-MEMS can provide more extensive training through personnel exchanges.*

### CALL FOR APPLICATIONS 1994

- Financial support to develop short courses
- Fundings for personnel placements

Duration: 2 to 12 months between May 1994 and August 1995.

University  Enterprise  
Transnationality

**Deadline: end of October 1993**

**TAKE YOUR CHANCE and contact us!**

for further information  
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